



APPLICATION DATA SHEET

Electronic Version 0.0.11

Stylesheet Version: 1.0

Attorney Docket Number: 740756-2688

Publication Filing Type: new-utility

Application Type: utility

AN EVALUATION METHOD USING A TEG, A METHOD OF
MANUFACTURING A SEMICONDUCTOR DEVICE HAVING A TEG, AN
ELEMENT SUBSTRATE AND A PANEL HAVING THE TEG, A PROGRAM
FOR CONTROLLING DOSAGE AND A COMPUTER-READABLE
RECORDING MEDIUM RECORDING THE PROGRAM

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22204

Foreign Priority:

2002-364411 JP 2002-12-16 Priority Claimed

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